p-Type Conductivity in N-Doped ZnO: The Role of the N_{Zn}-V_O Complex

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(Received 4 February 2012; published 23 May 2012)

Although nitrogen-doped zinc oxide has been fabricated as a light-emitting diode, the origin of its p-type conductivity remains mysterious. Here, by analyzing the surface reaction pathway of N in ZnO with first-principles density functional theory calculations, we demonstrate that the origin of p-type conductivity of N-doped ZnO can originate from the defect complexes of N_{Zn}-V_O and N_O-V_{Zn}. Favored by the Zn-polar growth, the shallow acceptor of N_O-V_{Zn} actually evolves from the double-donor state of N_{Zn}-V_O. While N_{Zn}-V_O is metastable, the p-doping mechanism of N_{Zn}-V_O \rightarrow N_O-V_{Zn} in ZnO will be free from the spontaneous compensation from the intrinsic donors. The results may offer clearer strategies for doping ZnO p-type more efficiently with N.

DOI: 10.1103/PhysRevLett.108.215501

PACS numbers: 61.72.Bb, 61.72.jd, 61.72.Yx, 71.55.Gs

As a well-known II-VI semiconductor, ZnO with the direct band gap of 3.37 eV at room temperature has a large exciton binding energy of 60 meV [1]. In comparison, GaN, with almost the same band gap, shows the exciton energy at about 20 meV [2]. Due to its large exciton energy, ZnO has been taken as a promising material to fabricate ultraviolet (UV) light emitters [3,4]. But, it suffers notoriously the doping asymmetry problem [5-7], i.e., it can be easily doped *n*-type but not *p*-type. Unlike GaN, whose light-emitting diodes (LEDs) and laser diodes have been successfully fabricated and commercialized, the optoelectronic application of ZnO has been hindered by lack of a practical and efficient *p*-doping method. While the quality of *p*-doping indeed decides the future of ZnO as a UV light-emitting material, in recent years great research efforts have been made to achieve sufficient *p*-type doping in ZnO, where acceptors are basically introduced with N [8,9], P [10], Sb [11], As [12], etc. Among those acceptor elements, N may be the best candidate for *p*-doping ZnO since it has the similar atomic radius and electronegativity as O [13]. Typically, for molecular beam epitaxy (MBE) growth, N-doping has been employed to fabricate *p*-type ZnO films by many groups. In 2002, Look et al. got the N-doped *p*-type ZnO layer with the hole concentration of 9×10^{16} cm⁻³ by MBE on an Li-diffused semi-insulating ZnO substrate [8]. In 2005, Tsukazaki et al. achieved p-i-n homojunction violet LEDs from the MBE-grown N-doped ZnO films on ScAlMgO₄ substrate, with a hole concentration of about 1×10^{16} cm⁻³ at 300 K [9]. In 2006, ZnO p-n junction LEDs were well fabricated on Al₂O₃ substrates by plasma-assisted MBE [14,15]. Moreover, in 2010, the UV electroluminescence emission was demonstrated on the N-doped Mg_xZn_{1-x}O $(0.1 \le x \le 0.4)$

films grown on the Zn-polar ZnO substrates by MBE [16]. Last year, MgZnO: N/ZnO/MgZnO double heterostructure UV LEDs were also fabricated with N-doped MgZnO layers[17].

However, despite the fact that UV LEDs have been successfully fabricated by N-doped ZnO materials, the origin of their p conductivity remains puzzling. In principle, the working of LEDs means N atoms bring shallow acceptors into ZnO. Experimentally, Look et al. assigned a photoluminescence line at 3.238 eV to a donor-acceptor transition, which suggests an estimated acceptor ionization energy of 170-200 meV [8]. But, the shallow acceptor nature of N in ZnO has not been supported by the theoretical studies. In 2001, based on the density functional theory (DFT) within the local-density-functional approximation (LDA), Lee et al. studied N-related defects and found only the O-site N (N_0) is an acceptor [18]. They indicated that N acceptors in ZnO are greatly compensated by N₂ molecules at oxygen sites and N-acceptor-N₂ complexes [18]. In 2002, with the LDA method, Park et al. suggested the defect level of substitutional N_O in ZnO is 0.4 eV [19]. In 2006, Li et al. reported their LDA calculation result that the (0/-) transition energy level of N_O is 0.31 eV [20]. As DFT-LDA calculations underestimate band gaps, it is argued that such results may bring large uncertainties in describing the defect levels in wide-bandgap materials [21]. In 2009, based on hybrid functional calculations, Lyons et al. found that No is actually a deep acceptor with an exceedingly high ionization energy of 1.3 eV and hence concluded that nitrogen cannot lead to hole conductivity in ZnO [21]. While little information on the chemical environment of N atoms in ZnO has been collected from experimental observations [8,9,14–17], the inconsistency between experimental and theoretical results cannot be solved. In fact, without a clear physics picture of the *p*-type conductivity in N-doped ZnO, it would be aimless to optimize its light-emitting performance. In this Letter, we demonstrate that the *p*-type nature of N-doped ZnO can originate from the defect complex composed of substitutional N_O and zinc vacancy V_{Zn} by analyzing its dynamic growth process. The N_O- V_{Zn} complex actually comes from the metastable donor defect of N_{Zn}- V_O , thus its *p*-type doping can survive the compensation during MBE growth. Considering the surface reaction pathway of N_{Zn}- V_O defects, we suggest the possible ways to achieve better *p*-type ZnO.

To our best knowledge, the theoretical studies so far regarding the electronic behaviors of N-doped ZnO are based on the bulk model simulations [5-7, 18-21], where the dynamic MBE growth process has not been taken into consideration. In fact, although wurtzite ZnO (w-ZnO) has distinctly two polar faces of Zn and O, typically only the Zn one is preferred to grow high-quality *p*-type ZnO with nitrogen during MBE processes [16,17]. That hints it may be the right way to bridge the gap between theoretical analysis and experimental observation of N-doped ZnO by simulating its dynamic growth process with polar surface dependence. Our first-principles calculations are based on DFT within Perdew-Burke-Ernzerhof (PBE) generalized gradient approximation [22] and the projected augmented wave (PAW) method [23-26]. When necessary, the hybrid functional calculation containing a mix of the exact exchange (36%) [21] and the PBE functional have been employed to calibrate the band gap of ZnO to its experimental value. The cutoff energy for the plane-wave basis set is 400 eV and the Brillouin zone is sampled with the kpoint separation <0.04 Å⁻¹. The experimental lattice parameters of ZnO at 4.2 K (a = 3.248 Å, c = 5.203 Å) [27] are used in building the structural models, where the atomic positions are relaxed until their residual forces are less than 0.01 eV Å⁻¹.

The absorption energies of N and O atoms absorbed on the Zn-polar surfaces of ZnO are calculated to understand their surface growth mechanism. We consider a 4×4 periodic slab geometry to represent the Zn-polar *w*-ZnO. The unit cell contains an atomic slab with eight(nine) atomic ZnO layers for the Zn-(O-) terminated surface and a vacuum region of larger than 15 Å. The bottom O layer of the slab is saturated with H atoms as shown in Fig. 1(a). Four possible absorption sites of N or O adatoms on the surface layers as shown in Figs. 1(b)–1(e) are selected to compare their absorption energies. During structural relaxation, the atomic positions of two bottom Zn and O layers are fixed. The absorption energy E_{abs} can be defined as:

$$E_{\rm abs} = E_{\rm slab+X}^{\rm tot} - E_{\rm slab}^{\rm tot} - \mu_X.$$
 (1)

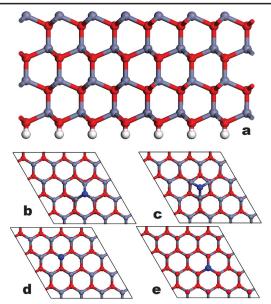


FIG. 1 (color). Side view of the periodic slab to represent the Zn-polar ZnO (a), the adsorption sites of hcp (b), fcc (c), and ontop (d) on Zn surface layer, and the adsorption site of hcp (e) on O surface layer. The gray, red, blue, and white balls represent Zn, O, N, and H atoms, respectively.

Here, $E_{\text{slab}+X}^{\text{tot}}$ is the total energy of the slab with a X adatom, $E_{\text{slab}}^{\text{tot}}$ is the total energy of the slab, and μ_X accounts for the chemical potential of adatom X. If μ_N is set to the energy per atom calculated for N₂, we have the absorption energy of the Zn surface as listed in Table I. We can see that N atoms have much higher absorption energy than O atoms at each possible high-symmetry site of the Zn surface. That indicates N atoms are not easy to attach to the Zn surface during the MBE growth of ZnO. However, for N at the hcp site of the Zn-polar O surface, i.e., N_{Zn} as shown in Fig. 1(e), its absorption energy is rather low at just 0.08 eV. Thus, as N atoms grow on the Zn-polar ZnO by MBE, they indeed prefer to form the Zn-site defects of N_{Zn} instead of the O-site ones of N_0 . On the contrary, N_{Zn} is dynamically unfavored if growing on the O-polar O surface, as it stays at the on-top site bonding to only one surface O atom. That may result in a NO molecule, free from the surface bonding. The calculated formation enthalpies of ZnO, O2, and N2 by PBE and their experimental values are listed in Table II, which suggest the PBE method may provide $\sim 94\%$ accuracy in describing the formation energies of N-doped ZnO structures.

TABLE I. Calculated absorption energy (in eV) of N and O at the high-symmetry sites of the Zn-polar Zn surface of ZnO.

	hcp	fcc	On-top
O(Zn-rich)	0.25	1.02	2.58
O(O-rich)	-3.16	-2.39	-0.83
N	1.36	1.90	4.14

TABLE II. Calculated formation enthalpy (in eV) of ZnO, O_2 , and N_2 by PBE and their experimental values.

	PBE	Expt
ZnO	3.41	3.61 [28]
O ₂	5.65	5.25 [29]
N ₂	10.38	9.89 [29]

At the first glance, the formation of N_{Zn} instead of N_O seems against the common sense that N should stay at the sites of anions. For a defect with charge q (X^q) in bulk ZnO, the formation energy $E(X^q)$ is defined as

$$E(X^{q}) = E_{tot}(X^{q}) - E_{tot} - \sum n_{i}\mu_{i} + q(E_{F} + E_{v} + \delta V).$$
(2)

Here, $E_{tot}(X^q)$ is the total energy of the supercell with some defect; E_{tot} is the total energy of the equivalent bulk ZnO supercell; n_i and μ_i are the atomic number and chemical potential of the species i; E_F is the Fermi level; E_v is the valence band maximum (VBM); and δV represents the potential shift between supercells. If simulated by the 192-atom (443) supercells of w-ZnO, the formation enthalpies of the defects can be plotted as functions of the Fermi level of E_F , as shown in Fig. 2. If under the neutral condition of $\Delta \mu_{\text{Zn}} = \Delta \mu_{\text{O}} = \frac{1}{2} H_f(\text{ZnO}) = -1.71 \text{ eV},$ N_{Zn} in bulk indeed has a higher formation energy than N_O . As two competitive processes, whether N_{Zn} or N_O dominates the MBE process relies on the growth condition. As N_{Zn} and N_O occupy the opposite sites of Zn and O, their formation energies in bulk ZnO depend reversely upon μ_{Zn} or μ_0 . That is N_{Zn} (N₀) in bulk ZnO has the lower formation energy under the O (Zn)-rich condition. However, that the Zn-polar growth N_{Zn} has a lower surface absorption energy than No gives it an advantage initially to form during the layer-by-layer growth. As to μ_N , both formation energies of N_{Zn} and N_O decrease with it from Eq. (2). In this manner, it is desirable to use NO or NO_2 as

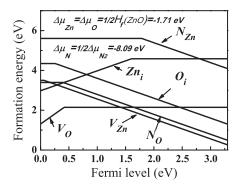


FIG. 2. Calculated PBE defect formation enthalpies as functions of the Fermi level E_F .

the doping source instead of N_2 [30] together with the plasma enhanced technique for MBE growth.

For a clearer understanding of the reaction path of N_{Zn} , the role of surface morphology of ZnO should be discussed as well. Obviously, N adatoms experience different bonding sequences following the surface polarity. On the Znpolar surface, N_{Zn} has three neighbor O atoms to bond. Whereas on the O-polar one, N_{Zn} can bond to only one O atom below. While fixed by two more N-O bonds, N_{Zn} on the Zn polar surface gets much more chance to survive the competition from Zn. Furthermore, during the Zn-polar growth, the coming O atoms sit just above the Zn atoms, rather than bonding three Zn atoms on the reverse polar face. For lower energy, the falling O atom will circumvent the N_{Zn} anion to bond to its neighbor Zn cations, and that results in a vacancy (V_0) on top of N_{Zn} , as shown in Fig. 3(a). Otherwise, after forming a NO molecule and free from the surface bonding, they will leave a Zn vacancy (V_{Zn}) , the intrinsic acceptor. In fact, N or Zn may also exist on top of N_{Zn}, forming defect complexes of N_{Zn}-N_O or N_{Zn}-Zn_O, respectively. As contributing no carriers, the trivial defect complex of N_{Zn} - N_O (N_2) will be neglected. The unstable complex of $N_{\mbox{Zn}}\mbox{-}\mbox{Zn}_{\mbox{O}}$ will degenerate into the well-studied defect of No. As acceptors, VZn and No suffer the compensation from the intrinsic donors.

Figure 3(a) draws the 192-atom (443) w-ZnO supercell containing a N_{Zn} - V_O complex. Such a complex may not be at the energy minimum, as it will evolve into the N_O-V_{Zn} complex if N_{Zn} jumps to its neighbor vacancy of O as shown in Fig. 3(b). To understand the thermal stability, the minimum energy path and energy barrier of from $N_{Zn}-V_{O}$ to $N_{O}-V_{Zn}$ has been identified with the elastic band method as plotted in Fig. 4. The simulated minimum energy path indicates the N_{Zn}-V_O complex is a metastable configuration with $\sim 0.5 \text{ eV}$ higher per supercell than $N_O - V_{Zn}$. While the energy barrier to $N_O - V_{Zn}$ is more than 1.1 eV, the N_{Zn} - V_O complex would survive the MBE growth of mild temperature. As a double donor, the formation of N_{Zn}-V_O will not trigger the spontaneous formation of intrinsic compensating defects in ZnO [31] as acceptors do. If activated after the epitaxy growth, the

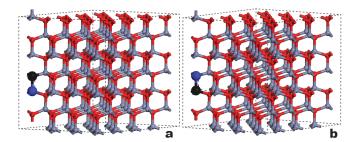


FIG. 3 (color). ZnO supercells with the N_{Zn} - V_O complex (a) and the N_O - V_{Zn} complex (b). The grey, red, blue, and black balls represent Zn, O, and N atoms and vacancy respectively.

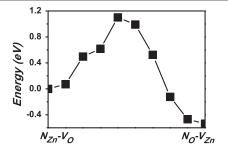


FIG. 4. Calculated minimum energy path from $N_{Zn}-V_O$ to N_O-V_{Zn} with the elastic band method.

transformed acceptor of N_O-V_{Zn} would overcome selfcompensation consequently with higher *p*-type conductivity in ZnO.

By examining the transition energy level $\varepsilon(0/-)$ of defects in ZnO, we find N_O-V_{Zn} is a shallow acceptor. Here, $\varepsilon(q/q')$ is defined as the Fermi-level position for which the formation energies of charge states q and q' are equal. The calculated $\varepsilon(0/-)$ of N_O is 0.40 eV that agrees with the published DFT results [18-20]. In comparison with that of N₀, the calculated $\varepsilon(0/-)$ of N₀-V_{Zn}, 0.11 eV is almost three times smaller. For PBE may underestimate the acceptor energy levels as well as $\varepsilon(0/-)$ as the case of N_0 [21], the electronic states of N_0-V_{Zn} have also be examined by the hybrid functional method. The hybrid functional results based on the (332) w-ZnO supercells indicate that the lowest acceptor state of $N_0 - V_{Z_p}$ stays 0.23 eV above VBM and its corresponding $\varepsilon(0/-)$ is 0.16 eV [32]. Therefore, the nature of double acceptor of N_O-V_{Zn} in ZnO has been confirmed shallow. Moreover, the calculated acceptor level of N-doped ZnO agrees with its experimental value, which has been reported to be about 135 meV from electrical measurements [33] and 150-210 meV from photoluminescence data [33,34].

In conclusion, the *p*-type conductivity of N-doped ZnO can originate from the defect complex of $N_0 - V_{Z_n}$ that is a shallow acceptor. N_O-V_{Zn} actually evolves from the metastable double donor of N_{Zn} - V_O that is favored by the Znpolar growth. While the energy barrier from $N_{Zn}-V_O$ to N_O-V_{Zn} is as high as 1.1 eV, the *p*-doping of N_O-V_{Zn} may survive the spontaneous self-compensation from intrinsic donors in ZnO. The reaction pathway of $N_{Zn}-V_O \rightarrow$ $N_{O}-V_{Zn}$ may lead to some strategies for more efficient p-doping in ZnO. They are as follows. (i) The Zn-polar growth should be selected. (ii) Plasma assisted sources of NO or NO₂ rather than pure N₂ would be desirable to increase the upper limit of μ_N for the higher N concentration. (iii) The Zn-polar growth condition has to balance between the Zn-rich and the O-rich. While the Zn-rich favors V_0 on top of N_{Zn} , more oxygen would be better for less intrinsic donors. (iv) As by the nonequilibrium growth, the N-doped samples containing $N_{Zn}-V_O$ complexes could be *n*-type, and they need to be activated to p-type for higher p conductivity. This also means it is advisable not to throw away a seemingly *n*-type sample unless it fails the LED test.

This work is supported by the National Basic Research Program of China (973 Program No. 2011CB302006 and No. 2011CB302005), the National Natural Science Foundation of China (No. 11174273 and No. 11134009), and the 100 Talents Program of the Chinese Academy of Sciences.

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